



Copy 12/29/98

Docket: 0756-958

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
SHUNPEI YAMAZAKI et al.)
Serial No. 08/183,800) Art Unit: 2811
Filed: 01/21/94) Examiner: S. Crane
For: SEMICONDUCTOR MATERIAL AND)
METHOD FOR FORMING THE SAME AND)
THIN FILM TRANSISTOR)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service with sufficient postage as
First Class Mail in an envelope addressed to: Assistant
Commissioner For Patents Washington, D.C. 20231, on
12-29-98

James L. Linton

AMENDMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the *Office Action* mailed on September 29, 1998, please
amend the above-identified application as follows:

01/11/1999 ZABDALLA 00000035 08183800

01 FC:103

126.00 OP

RECEIVED

JAN 12 1999

GROUP 2100

RECEIVED

FEB 24 1999

OFFICE OF PETITIONS
DEPUTY A/C PATENTS

L